	ES (DOCUMENT	CHANGE REQUEST	
DCR number	1061	Changes required for:	Qualification	Originator: Fernando Martinez	
Date: 2017/05	5/09	Date sent: 2017/03/01		Organisation: ESTEC	
Status: IMPLEMENTED					
Title:	ESCC Qualified Manufacturers List REP006				
Number:	REP006	Issue:	14		
Other documents affected:					
Page:					
several					
Paragraph:					
several					
Original wording:					
see published QML					
Proposed wording:					
see draft					
Justification:					
 QML update to account for: revised scope of Qualification for Microchip Atmel Technology Flows. extended qualification validity period for Vishay Sfernice Technology Flow added Process Capability Approvals for hermetic hybrid production lines of Airbus Defence and Space (France) and Safran-Sagem (France) 					
And some other editorial changes that affect bullet/ sub-paragraph numbers inside paragraphs as a result of the mentioned additions.					

Attachments:			
esccrpqml006_15_draft.docx			
Modifications:			
N/A			
Approval signature:			
Rectario			
Date signed:			
2017-05-09			